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Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				<b>Complete If Known</b>	
				Application Number	10/687,458-Conf. #8780
				Filing Date	October 15, 2003
				First Named Inventor	David J. Kubista
				Art Unit	1763
				Examiner Name	Rudy Zervigon
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
J		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
		US-11/018,142	Filed 12-20-2004	Rueger et al.	
		US-10/840,571	Filed 05-06-2004	Dando et al.	
		US-10/859,883	Filed 06-02-2004	Miller et al.	
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		US-3,618,919	11-09-1971	Beck	
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V		US-3,630,881	12-28-1971	Lester et al.	
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✓	US-4,289,061	09-15-1981	Emmett	
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	US-5,480,818	01-02-1996	Matsumoto et al.	
	US-5,498,292	03-12-1996	Ozaki	
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Examiner Signature	<i>Rudy Zervigon</i>	Date Considered	11/8/05
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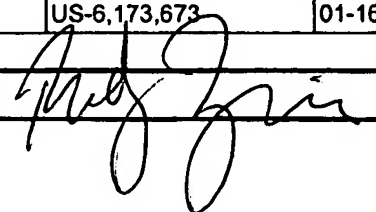
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				Application Number	10/687,458—Conf. #8780
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✓	US-5,522,934	06-04-1996	Suzuki et al.	
	US-5,536,317	07-16-1996	Crain et al.	
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	US-5,640,751	06-24-1997	Faria	
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	US-5,693,288	12-02-1997	Nakamura	
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	US-5,972,430	10-26-1999	DiMeo, Jr. et al.	
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	US-6,123,107	09-26-2000	Selser et al.	
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	US-6,144,060	11-07-2000	Park et al.	
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	US-6,174,377	01-16-2001	Doering et al.	
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	US-6,270,572	08-07-2001	Kim et al.	
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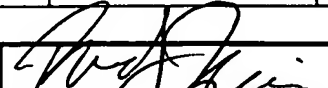
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	US-6,329,297	12-11-2001	Balish et al.	
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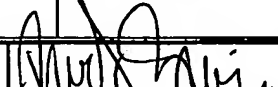


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				First Named Inventor	David J. Kubista
				Art Unit	1763
				Examiner Name	Rudy Zervigon
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Examiner Signature	<i>Rudy Zervigon</i>	Date Considered	11/8/05
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				Examiner Name	Rudy Zervigon
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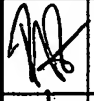

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
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